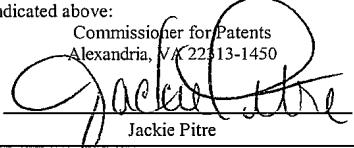


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/506,956  
Confirmation No.: 8795  
Filed: March 24, 2005  
Inventor(s): Agrawal, C.M.  
Title: GAS PLASMA TREATMENT  
OF IMPLANTS

§ Examiner: David Naff  
§ Art Unit: 1657  
§ Atty. Dkt. No: 5660-00503

CERTIFICATE OF ELECTRONIC FILING UNDER 37 C.F.R. §1.8	
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I hereby certify that this correspondence is being deposited with the United States patent office using the EFS-Web Service on the date indicated above:	
Commissioner for Patents Alexandria, VA 22313-1450	
Jackie Pitre	

AMENDMENT/RESPONSE TO OFFICE ACTION MAILED JULY 2, 2007

**Mail Stop: AMENDMENT**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please amend the above-captioned application as follows:

*Amendments to the Specification* begin on page 2 of this paper;

*Amendments to the Claims* begin on page 3 of this paper; and

*Remarks* begin on page 8 of this paper.